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CONFIRMATION NO. 8539

SERIAL NUMBER 10/645,908	FILING OR 371(c) DATE 08/22/2003 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. 2003_1164A
APPLICANTS Yoichiro Numasawa, Tokyo, JAPAN; Yukinobu Murao, Tokyo, JAPAN;				
** CONTINUING DATA ***** <i>None AICS</i>				
** FOREIGN APPLICATIONS ***** <i>Yes AICS</i> JAPAN 2002-243342 08/23/2002				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/29/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Asst. Examiner</i> Acknowledged <i>Sarkar</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 20
INDEPENDENT CLAIMS 2				
ADDRESS 513				
TITLE Method of forming an oxygen- or nitrogen-terminated silicon nanocrystalline structure and an oxygen- or nitrogen-terminated silicon nanocrystalline structure formed by the method				
FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	